

Docket No.: 4590-523

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : EXPEDITED PROCEDURE  
: Response under 37 CFR 1.116

Pierre BLANCHARD : Confirmation No. 7171

U.S. Patent Application No. 10/582,711 : Group Art Unit: 2892

Filed: June 12, 2006 : Examiner: Jones, Eric W.

For: METHOD FOR PRODUCING ELECTRONIC CHIPS CONSISTING OF THINNED SILICON

**RESPONSE UNDER 37 CFR § 1.116**

Mail Stop AF  
Commissioner for Patents  
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Sir:

This paper is submitted in reply to the Office Action mailed February 18, 2009, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.

**Amendments to the Claims – page 2**

**Remarks/Arguments – page 6**